(19) World Intellectual Property Organization International Bureau



(43) International Publication Date 18 January 2001 (18.01.2001)

PCT

(10) International Publication Number WO 01/04643 A3

(51) International Patent Classification⁷: G01R 31/316, 31/28, 1/04

(21) International Application Number: PCT/US00/19391

(22) International Filing Date: 13 July 2000 (13.07.2000)

(25) Filing Language: English

(26) Publication Language: English

(30) Priority Data:

 09/353,214
 14 July 1999 (14.07.1999)
 US

 09/353,116
 14 July 1999 (14.07.1999)
 US

 09/353,121
 14 July 1999 (14.07.1999)
 US

- (71) Applicant (for all designated States except US): AEHR TEST SYSTEMS [US/US]; 400 Kato Terrace, Fremont, CA 94539 (US).
- (72) Inventors; and
- (75) Inventors/Applicants (for US only): UHER, Frank, Otto [US/US]; 1221 Richardson Avenue, Los Altos, CA 94024 (US). ANDBERG, John, William [US/US]; 305 Highview Court, Santa Cruz, CA 95060 (US). CARBONE, Mark, Charles [US/US]; 2532 West Middlefield Road,

Mountain View, CA 94043 (US). RICHMOND, Donald, Paul, II [US/US]; 743 Montrose Avenue, Palo Alto, CA 94303 (US).

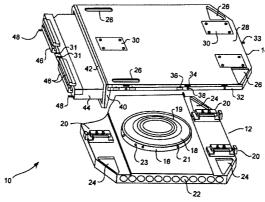
- (74) Agents: ABRAHAM, David, J.; Wilson, Sonsini, Goodrich & Rosati, 650 Page Mill Road, Palo Alto, CA 94304-1050 et al. (US).
- (81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CR, CU, CZ, DE, DK, DM, DZ, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NO, NZ, PL, PT, RO, RU, SD, SE, SG, SI, SK, SL, TJ, TM, TR, TT, TZ, UA, UG, US, UZ, VN, YU, ZA, ZW.
- (84) Designated States (regional): ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, CH, CY, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GW, ML, MR, NE, SN, TD, TG).

Published:

with international search report

[Continued on next page]

(54) Title: WAFER-LEVEL BURN-IN AND TEST CARTRIDGE AND METHODS



(57) Abstract: A cartridge (10) includes a chuck plate (12) for receiving a wafer (74) and a probe plate (14) for establishing electrical contact with the wafer. In use, a mechanical connecting device (90) locks the chuck plate and the probe plate fixed relative to one another to maintain alignment of the wafer and the probe plate. Preferably, electrical contact with the wafer is established using a probe card (50) that is movably mounted to the probe plate by means of a plurality of leaf springs (52). The mechanical connecting device is preferably a kinematic coupling including a male connector (94) and first and second opposed jaws (122, 124). Each of the jaws is pivotable from a retracted position in which the male connector can be inserted between the jaws and an engaging position in which the jaws prevent withdrawal of the male connector from between the jaws. The male connector is movable between an extended and a retracted position, and is biased towards the retracted position. This provides a positive clamping force that pulls the chuck and probe plates together when the mechanical connecting device is engaged. To leaf a wafer into the cartridge, the wafer is placed on the chuck plate, the probe plate is aligned with the wafer, and the chuck plate and the probe plate are locked together. The cartridge can then be removed from the alignment device and placed in a burn-in or test chamber that does not itself require means for aligning the wafer or for providing a probe actuation force.



VO 01/04643 A3

WO 01/04643 A3



(88) Date of publication of the international search report: 18 April 2002

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

INTF "NATIONAL SEARCH REPORT

Internat. .i Application No PCT/US 00/19391

A. CLASSIFICATION OF SUBJECT MATTER IPC 7 G01R31/316 G01R31/28 G01R1/04

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols) IPC 7 GO1R HO1L

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	JP 08 005666 A (MATSUSHITA ELECTRIC IND CO LTD) 12 January 1996 (1996-01-12)	1-14, 21-30, 38,39, 41-46, 48-62, 64-74, 76-86, 88-90, 93-98
	the whole document -& JP 10 189670 A (MATSUSHITA ELECTRIC IND CO LTD) 21 July 1998 (1998-07-21) the whole document	
P,X	-& US 5 945 834 A (HATADA KENZOU ET AL) 31 August 1999 (1999-08-31)	1-14, 21-30, 38,39, 41-46, 48-62, 64-74,

° Special categories of cited documents	*T* later document published after the international filing date		
A document defining the general state of the art which is not considered to be of particular relevance	or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention		
E earlier document but published on or after the international filing date	'X' document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to		
L document which may throw doubts on priority_claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)	involve an inventive step when the document is taken alone 'Y' document of particular relevance; the claimed invention		
 O document referring to an oral disclosure, use. exhibition or other means 	cannot be considered to involve an inventive step when the document is combined with one or more other such docu- ments, such combination being obvious to a person skilled		
P document published prior to the international filing date but later than the priority date claimed	in the art. '&' document member of the same patent family		
Date of the actual completion of the international search	Date of mailing of the international search report		
15 June 2001	2 7. 06. 01		
Name and mailing address of the ISA	Authorized officer		
European Patent Office, P.B. 5818 Patentlaan 2 NL - 2280 HV Rijswijk			

4

INTF NATIONAL SEARCH REPORT

Internat. JApplication No PCT/US 00/19391

C.(Continu	ation) DOCUMENTS CONSIDERED TO BE RELEVANT	
ategory °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
	column 17, line 14 -column 18, line 52; figures 1,2,12 column 19, line 17 - line 44; figure 4 column 22, line 48 -column 24, line 22; figures 13,14 column 28, line 62 -column 29, line 55; figure 18	76-86, 88-90, 93-98
(EP 0 283 219 A (HEWLETT PACKARD CO) 21 September 1988 (1988-09-21) column 3, line 32 -column 6, line 10; figures 1-4	29-32, 37,40
(US 4 818 933 A (KERSCHNER RONALD K ET AL) 4 April 1989 (1989-04-04) column 9, line 23 -column 10, line 2; figure 7	47
(US 5 808 474 A (HIVELY JAMES W ET AL) 15 September 1998 (1998-09-15) abstract; figure 1	47
(US 5 621 313 A (TSUTA KIYOAKI) 15 April 1997 (1997-04-15) column 3, line 60 -column 4, line 27; figure 1	91,92
X	US 5 777 485 A (AKAIKE SHINJI ET AL) 7 July 1998 (1998-07-07) column 13, line 27 - line 48; figures 18,19	91

International application No. PCT/US 00/19391

INTERNATIONAL SEARCH REPORT

Box I	Observations where certain claims were found unsearchable (Continuation of item 1 of first sheet)
This Inte	ernational Search Report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:
1.	Claims Nos.: because they relate to subject matter not required to be searched by this Authority, namely:
2.	Claims Nos.: because they relate to parts of the International Application that do not comply with the prescribed requirements to such an extent that no meaningful International Search can be carried out, specifically:
3.	Claims Nos.: because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).
Box II	Observations where unity of invention is lacking (Continuation of item 2 of first sheet)
This Inte	ernational Searching Authority found multiple inventions in this international application, as follows:
	see additional sheet
1. χ	As all required additional search fees were timely paid by the applicant, this International Search Report covers all searchable claims.
2.	As all searchable claims could be searched without effort justifying an additional fee, this Authority did not invite payment of any additional fee.
3.	As only some of the required additional search fees were timely paid by the applicant, this International Search Report covers only those claims for which fees were paid, specifically claims Nos.:
4.	No required additional search fees were timely paid by the applicant. Consequently, this International Search Report is restricted to the invention first mentioned in the claims; it is covered by claims Nos.:
Remark	on Protest The additional search fees were accompanied by the applicant's protest. X No protest accompanied the payment of additional search fees.

FURTHER INFORMATION CONTINUED FROM PCT/ISA/ 210

This International Searching Authority found multiple (groups of) inventions in this international application, as follows:

1. Claims: 1-20,23-26,29-37,40-44,46,48,54-56,63,68 partially, 75 partially,79,80,87

Compliant mounting of a probe card to a probe plate in a burn-in or test cartridge by using leaf springs

2. Claims: 21,22,27,28,38,39,45,57,59-62,64, and 69-74,76, 81-86,88,98 all partially

Device and method to press the probe card against the wafer in a burn-in or test cartridge allowing the use of either an increased or decreased air pressure

3. Claims: 47,49-53,67,58,65,66,67,77,78,89,90,93-97

Locking means for a probe plate and a chuck plate in burn-in or test cartridge allowing lateral movement between the two plates before the locking

4. Claims: 91,92

Method for simultaneously placing and aligning of a wafer on a chuck plate by capturing an image of the wafer and determining from the image an aligned position for the wafer.

INTE NATIONAL SEARCH REPORT

Information on patent family members

Internat. al Application No
PCT/US 00/19391

Patent document cited in search report		Publication date	Patent family member(s)		Publication date	
JP 08	005666	A	12-01-1996	KR US US	140034 B 5945834 A 6005401 A	15-07-1998 31-08-1999 21-12-1999
EP 02	83219	A	21-09-1988	DE DE DE EP HK JP	3850664 D 3850664 T 3882158 A 3882158 T 0369554 A 43394 A 63252438 A	18-08-1994 20-10-1994 12-08-1993 27-01-1994 23-05-1990 13-05-1994 19-10-1988
US 48	18933	A	04-04-1989	DE EP JP JP	3765740 D 0263307 A 2585024 B 63184076 A	29-11-1990 13-04-1988 26-02-1997 29-07-1988
US 58	08474	Α	15-09-1998	NONE		
US 56	21313	Α	15-04-1997	NONE		
US 57	77485	A	07-07-1998	JP JP JP JP JP	3138908 B 8321529 A 9199553 A 3138924 B 11145221 A	26-02-2001 03-12-1996 31-07-1997 26-02-2001 28-05-1999